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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Kim et al.

Serial No.: 10/683,937

Confirmation No.: 2191

Filed: October 10, 2003

For: Methods of Selective  
Deposition of Heavily  
Doped Epitaxial SiGe§  
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Group Art Unit: 2822

Examiner: Michael Manh Trinh

MAIL STOP AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450CERTIFICATE OF MAILING  
37 CFR 1.8I hereby certify that this correspondence is being deposited on  
September 16, 2005 with the United States Postal Service as  
First Class Mail in an envelope addressed to: Commissioner  
for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

September 16, 2005

Date

Signature

Dear Sir:

## RESPONSE TO OFFICE ACTION DATED JUNE 16, 2005

In response to the Office Action dated June 16, 2005, having a shortened statutory period for response set to expire on September 16, 2005, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although the Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/8539/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

**Amendments to the Claims** begin on page 2 of this paper. **Remarks** begin on page 7 of this paper.